

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Grimbergen, et al.	Group Art Unit. 1763
Serial No: 09/610,237	Examiner: Jeffrie Lund
Filed: 7/5/2000	Attorney Docket No: 002813 USA D01/ETCH/SILICON/JB
For: Chamber Having Process Monitoring Window	November 6, 2001 San Francisco, California

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## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Box Non-Fee Amendment  
Commissioner for Patents  
Washington, D.C. 20231

Sir/Madam:

Attached hereto are PTO-1449 forms listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and initialed copies of the forms be returned to the undersigned.

Under 37 C.F.R. § 1.97(b) (3), an Information Disclosure Statement shall be considered by the Office if filed before the mailing date of the first office action.

It is believed that no fee is due for the filing of this Information Disclosure Statement. However, if any fee is due, the Commissioner is hereby authorized to charge payment of any such fees to Deposit Account No. 10-0258

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on  
November 6, 2001.

By

  
Rowena Montoya

S/N: 09/610,237

Page 2 of 2

Also, if any Petition is required for the filing of this Information Disclosure Statement, such Petition is requested herein.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

With regard to any translations which may be provided herewith, the undersigned does not know how and who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

These documents are not necessarily analogous.

Respectfully submitted,

JANAH & ASSOCIATES  
A PROFESSIONAL CORPORATION

Date: November 6, 2001

By: 

Ashok K. Janah  
Reg. No. 37,487

Please direct all telephone calls to Ashok K. Janah at (415)538-1555.

Please continue to send all correspondence to:

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Encl.

JANAH & ASSOCIATES, PC  
650 Delancey Street, Suite 106  
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**VIA FACSIMILE**

ATTENTION: Jeffrie Lund  
GROUP ART UNIT: 1763  
FIRM/CO. NAME: United States Patent and Trademark Office  
SERIAL NO.: 09/610,237  
FAX NO.: (703) 872-9628  
FROM: Ashok K. Janah  
DATE: November 6, 2001  
OUR REFERENCE NO.: 002813 USA D01/ETCH/SILICON/JB

TOTAL NUMBER OF PAGES 32 (INCLUDING COVER PAGE)

IF YOU DO NOT RECEIVE ALL PAGES, PLEASE CALL: Rowena

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MESSAGE:

Examiner Lund,

Please see the attached Supplemental Information Disclosure Statement (2 pages), PTO-1449 form (1 page), and citation (28 pages).

I thank you,

Rowena

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